



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yukiya HIRABAYASHI

Group Art Unit: 2871

Application No.: 09/776,678

Examiner: H. NGO

Filed: February 6, 2001

Docket No.: 108020

For: SEMICONDUCTOR DEVICE, ELECTRO-OPTICAL DEVICE SUBSTRATE, LIQUID CRYSTAL DEVICE SUBSTRATE AND MANUFACTURING METHOD THEREFOR, LIQUID CRYSTAL DEVICE, AND PROJECTION LIQUID CRYSTAL DISPLAY DEVICE AND ELECTRONIC APPARATUS USING THE LIQUID CRYSTAL DEVICE

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the September 30, 2003 Restriction Requirement, Applicant provisionally elects Group I, claims 1-14, with traverse.

It is also respectfully submitted that the subject matter of all claims 1-18 is sufficiently related that a thorough search for the subject matter of any one Group of claims would encompass a search for the subject matter of the remaining claims. Thus, it is respectfully submitted that the search and examination of the entire application could be made without serious burden. See MPEP §803 in which it is stated that "if the search and examination of an entire application can be made without serious burden, the examiner must examine it on the merits, even though it includes claims to independent or distinct inventions" (emphasis added). It is respectfully submitted that this policy should apply in the present application in

order to avoid unnecessary delay and expense to Applicant and duplicative examination by the Patent Office.

Thus, withdrawal of the Restriction Requirement is respectfully requested.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

Kevin M. McKinley
Registration No. 43,794

JAO:KMM/jfb

Date: October 30, 2003

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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